

1. Record Nr.	UNINA9910787633803321
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Titolo	Ion implantation and activation . Volume 3 / / Kunihiro Suzuki
Pubbl/distr/stampa	Sharjah : , : Bentham Science Publishers, , 2013
ISBN	1-60805-792-5
Descrizione fisica	1 online resource (212 p.)
Collana	Ion Implantation and Activation
Soggetti	Ion implantation Ion accelerators
Lingua di pubblicazione	Inglese
Formato	Materiale a stampa
Livello bibliografico	Monografia
Note generali	Description based upon print version of record.
Nota di bibliografia	Includes bibliographical references and index.
Nota di contenuto	Cover; Title; EUL; Contents; Preface; Acknowledgement; Chapter 01; Chapter 02; Chapter 03; Chapter 04; Chapter 05; Chapter 06; Chapter 07; Index
Sommario/riassunto	Ion Implantation and Activation presents the derivation process of related models in a comprehensive step by step manner starting from the fundamental processes and moving up into the more advanced theories.Chapters in the book explain, in depth, various topics such as Pearson functions, LSS theory, Monte Carlo simulations, Edgeworth Polynomials and much more. This book provides advanced engineering and physics students and researchers with complete and coherent coverage of modern semiconductor process modeling.